

Ref #	Hits	Search Query	DBs	Default Operator	Plurals	Time Stamp
S1	1	"6670283"	US-PGPUB; USPAT	OR	ON	2005/08/23 19:24
S2	1	("20030096507").PN.	US-PGPUB; USPAT	OR	OFF	2005/08/23 19:25
S3	10	((("4053335") or ("4687682") or ("5006202") or ("5201987") or ("5296385") or ("5562770") or ("5856230") or ("6017828") or ("6153536") or ("6180318"))).PN.	US-PGPUB; USPAT	OR	OFF	2005/08/23 20:06
S4	23	"4687682"	US-PGPUB; USPAT	OR	ON	2005/08/23 20:06
S5	26	"4687682"	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/08/23 20:20
S6	9	auto\$1doping same (sheet adj resistance)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/08/23 20:30
S7	60	auto\$1doping and ((nitride near (cap capping capped)) (oxide near (cap capping capped)))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/08/23 20:42
S8	448	(sheet adj resistance) with uniform	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/08/23 20:42
S9	48	S8 and ((plurality multiple lot) with (wafer substrate))	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/08/23 20:43
S10	128	438/503.ccls.	US-PGPUB; USPAT	OR	ON	2005/08/23 21:13
S11	641	furnace with (epitaxial near grow\$5)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/08/25 19:11

S12	2	S11 with (LPCVD low\$1pressure\$1chemical\$1vapor)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/08/25 19:09
S13	2	S11 same (LPCVD low\$1pressure\$1chemical\$1vapor)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/08/25 19:18
S14	97	(epitaxial near grow\$5) with (LPCVD low\$1pressure\$1chemical\$1vapor)	US-PGPUB; USPAT; USOCR; EPO; JPO; DERWENT; IBM_TDB	OR	ON	2005/08/25 19:10

EAST *QPM*